Applicant Initiated Interview Request Form -- faxed to: 571. 270. 8538 (1 pp.)

In re the Application of

Hiroyuki NAGASAKA

Group Art Unit:

2851

Application No.: 10/589,962

Examiner:

C. RIDDLE

Filed: August 18, 2006

Docket No.:

128675

For:

EXPOSURE METHOD, EXPOSURE APPARATUS, EXPOSURE SYSTEM AND DEVICE

MANUFACTURING METHOD

	rview: TBD ested: (2) Personal Demonstrated: YES	2) Examiner Riddle 4) Proposed Time: (3) Video Confe	rence	(AN	
Issues To Be Discussed					
Issues (Rej., Obj., etc)	Claims/ Fig. #s	Prior Art	Discussed	Agreed	Not Agreed
(1) Rejection	2, 13, 32	Sugita, Kudo			
(2)					
(3)					
Continuation Sheet Attached Brief Description of Arguments to be Presented: Based upon the law as set forth in MPEP §§2141(V) and 2145(X)(D)(3), the claims would not have been obvious in view of the applied references. Applicant's representative would like to discuss the rejections in view of the above					
referenced sections of the MPEP and determine if further evidence would be necessary in support of these arguments.					
An interview was conducted on the above-identified application on					
NOTE:					
This form should be completed by applicant and submitted to the examiner in advance of the interview (see MPEP § 713.01).					
This application will not be delayed from Issue because of applicant's failure to submit a written record of this interview. Therefore, applicant is advised to file a statement of substance of this interview (37 CFR 1.133(b) as soon as possible.					
(Applicant/Applicant's Representative Signature) (Examiner/SPE Signature)					